Surface Analysis Technology	Vacuum Components	S P€	CS®	Surface Analysis System Software	Computer Technology
SPM 150 Aarhus with KolibriSensor™					
Atomic Resolution NC-AFM on Si(111)-(7x7)					
Applicati	on Notes				
Highest Reso	lution, constant c	letuning NC-AFM ir	naging at roon	n temperature	
Atomic corrug	gation up to 120	om			
Stable imaging of adsorbates and vacancies on the surface					
Identification of faulted and unfaulted half in NC-AFM images					
Atomic resolution imaging of an atomic step					
Constant detuning imaging in the repulsive interaction region with atomic resolution					
All of the follo system at SPEC Displayed images	owing data wa S' Laboratorie represent raw da	s recorded with s. hta with no filtering	no externa	l dampers on a	the UHV
Measurement: S.	Torbrügge, SPECS	6 GmbH	Kolibr	iSensor™	VI

### SP&CS® Highest Resolution NC-AFM imaging on Si(111)-(7x7)



forward scan

backward scan

Figure 1: Constant detuning NC-AFM image.

Image size: 6 nm x 6 nm,  $f_{res}$  = 996,577 Hz, Q= 17500,  $\Delta f$  = -0.3 Hz, A = 200 pm,  $U_{CPD}$  = 0.070 V, imaging speed: <u>2.5 lines/s</u>, (512 x 512) pixels

### SP&CS® Highest Resolution NC-AFM imaging on Si(111)-(7x7)



forward scan

backward scan

#### Figure 2: Constant detuning NC-AFM image.

Image size: 6 nm x 6 nm,  $f_{res}$  = 996,577 Hz, Q= 17500,  $\Delta f$  = -0.5 Hz, A = 200 pm,  $U_{CPD}$  = 0.070 V, imaging speed: <u>2.5 lines/s</u>, (256 x 256) pixels

### SP&CS® Highest Resolution NC-AFM imaging on Si(111)-(7x7)



forward scan

backward scan

Figure 3: Constant detuning NC-AFM image.

Image size: 6 nm x 6 nm,  $f_{res} = 996,577$  Hz, Q= 17500,  $\Delta f = -0.3$  Hz, A = 200 pm,  $U_{CPD} = 0.070$  V, imaging speed: <u>20 lines/s</u>, (512 x 512) pixels

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### **Highest Resolution NC-AFM imaging on Si(111)-(7x7)**

### scanning speed: 400 ms/line



scanning speed: 50 ms/line





#### Figure 4: Height Profile Analysis

A typical corrugation of 120 pm is observed

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# NC-AFM imaging of adsorbates and vacancies on Si(111)-(7x7)



#### Figure 5: Constant detuning image of defects on the Si(111)-(7x7) surface

Image size: 15 nm x 15 nm,  $f_{res}$  = 996,577 Hz, Q= 17500,  $\Delta f$  = -0.45 Hz, A = 200 pm, U<sub>CPD</sub> = 0.070 V, imaging speed: 2.5 lines/s, (512 x 512) pixels

### S P C S <sup>®</sup> NC-AFM imaging of clean and defective areas on Si(111)-(7x7)



Figure 6: NC-AFM constant detuning (topography) imaging of defects on the surface.

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### Identification of faulted and unfaulted half on Si(111)-(7x7) in NC-AFM imaging



Figure 7: NC-AFM constant detuning (topography) image of the faulted and unfaulted half Image size: 12 nm x 12 nm,  $f_{res} = 996,577$  Hz, Q= 17500,  $\Delta f = -0.60$  Hz, A = 200 pm,  $U_{CPD} = -0.19$  V, imaging speed: 6.6 lines/s, (512 x 512) pixels

The faulted half is contrasted bright compared with the unfaulted half, and the corner hole adatoms are observed brighter than the center adatoms [1].

[1] Atomically resolved imaging by low-temperature frequency-modulation atomic force microscopy using a quartz length-extension resonator T. An et al, Rev. Sci. Instrum., **79**, 033703 (2008) Competence in Surface Analysis

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### NC-AFM imaging of an atomic step on Si(111)-(7x7)



Figure 8: NC-AFM constant detuning image of an atomic step

Image size: 20 nm x 20nm,  $f_{res}$  = 996,577 Hz, Q= 17500,  $\Delta f$  = -0.33 Hz, A = 200 pm,  $U_{CPD}$  = 0.070 V, imaging speed: 2.0 lines/s, (512 x 512) pixels

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## SP&CS<sup>®</sup>

Atomically resolved NC-AFM imaging in the attractive and repulsive regime on Si(111)-(7x7)



### SP&CS<sup>®</sup> Repulsive region imaging on Si(111)-(7x7)



## Figure 10: Consecutive recorded constant detuning images in the repulsive region

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Image size: (20 x 20), (15 x 15), (12 x 12), (8 x 8) nm<sup>2</sup>, f<sub>res</sub> = 996,577 Hz, Q= 17500,  $\Delta f = + 0.44$  Hz, A = 200 pm, U<sub>CPD</sub> = 0.070 V, imaging speed: 3.5 lines/s, (512 x 512) pixels, respectively